

Applicant(s)	Xingwu Yang et al.	<b>INFORMATION DISCLOSURE STATEMENT FORM PTO-1449</b>
Serial No.	Unknown	
Filing Date	Unknown	
Group Art Unit	Unknown	
Examiner Name	Unknown	
Attorney Docket No.	125.021US02	
Title: MAGNETIC THIN FILM INDUCTORS		Sheet 1 of 2

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